Translation

PATENT COOPERATION TREATY



PCT

INTERNATIONAL PRELIMINARY EXAMINATION REPORT

(PCT Article 36 and Rule 70)

Applicant's or agent's file reference NE-70223WO	FOR FURTHER ACT	1 Teliminary Examination Report (1 o.m. 1 o - 1					
International application No. PCT/JP2003/012146	International filing date 24 September 200		Priority date (day/month/year)				
International Patent Classification (IPC) or n H01L 21/205, 21/302	ational classification and	IPC					
Applicant	NEC CORPC	PRATION					
 This international preliminary examination report has been prepared by this International Preliminary Examining Authority and is transmitted to the applicant according to Article 36. 							
2. This REPORT consists of a total of 4 sheets, including this cover sheet.							
This report is also accompanied by ANNEXES, i.e., sheets of the description, claims and/or drawings which have been amended and are the basis for this report and/or sheets containing rectifications made before this Authority (see Rule 70.16 and Section 607 of the Administrative Instructions under the PCT).							
These annexes consist of a total of sheets.							
3. This report contains indications relating to the following items:							
I Basis of the report							
II Priority			1				
III Non-establishment	t of opinion with regard to	novelty, inventive s	tep and industrial applicability				
IV Lack of unity of in	Lock of unity of invention						
V Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement							
VI Certain documents cited							
VII Certain defects in the international application							
VIII Certain observations on the international application							
Date of submission of the demand		Date of completion	of this report				
24 September 2003 (24	.09.2003)	02	2 April 2004 (02.04.2004)				
Name and mailing address of the IPEA/JP		Authorized officer					
Facsimile No.		Telephone No.					

INTERNATIONAL PRELIMINARY EXAMINATION REPORT

International application No.

PCT/JP2003/012146

I. I	Basis o	of the re	port	
1.	With r	regard to	the elements of the international application:*	
	\boxtimes	the inter	rnational application as originally filed	
Ì		the desc	cription:	
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		pages	, filed with the letter of	
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l	H		egether with the international application in computer readable form.	
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	Ħ		thed subsequently to this Authority in computer readable form.	
ļ		The s	statement that the subsequently furnished written sequence listing does not go beyond actional application as filed has been furnished.	the disclosure in the
		The s	statement that the information recorded in computer readable form is identical to the written furnished.	n sequence listing has
4	. 🔲	The a	mendments have resulted in the cancellation of:	
l			the description, pages	
١			the claims, Nos.	
			the drawings, sheets/fig	
5	. 🗆	This re	eport has been established as if (some of) the amendments had not been made, since they have d the disclosure as filed, as indicated in the Supplemental Box (Rule 70.2(c)).**	been considered to go
1	in t	lacement his repo 70.17).	t sheets which have been furnished to the receiving Office in response to an invitation under Ar ort as "originally filed" and are not annexed to this report since they do not contain an	ticle 14 are referred to sendments (Rule 70.16
1.			ment sheet containing such amendments must be referred to under item 1 and annexed to this rep	port.
1		, op 10001		

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le 35(2) with regard to no orting such statement	ovelty, inventive step or industrial applicability	•
		YES
Claims	4-10, 22-28, 38-48	
Claims	1-3, 11-21, 29-37	NO
Claims	4-10, 22-28, 39-48	YES
Claims	1-3, 11-21, 29-38	NO
Claims	1-48	YES
Claims		NO
	Claims Claims Claims Claims Claims Claims Claims	Claims 4-10, 22-28, 38-48 Claims 1-3, 11-21, 29-37 Claims 4-10, 22-28, 39-48 Claims 1-3, 11-21, 29-38 Claims 1-48

2. Citations and explanations

Document 1: JP, 59-065434, A (NEC CORPORATION), 13 April 1984 (13.04.84) (Family: none) Document 2: US, 5400740, A (MITSUBISHI CHEMICAL CORPORATION), 28 March 1995 (28.03.95), full text & JP, 5-175150, A

Document 3: JP, 3-236219, A (SUMITOMO ELECTRIC INDUSTRIES, LTD.), 22 October 1991 (22.10.91), full text (Family: none)

Document 4: JP, 9-092621, A (OKI ELECTRIC INDUSTRY CO., LTD.), 04 April 1997 (04.04.97), full text (Family: none)

Document 5: JP, 1-286991, A (FUJITSU LIMITED), 17 November 1989 (17.11.89), page 4, upper left column, lines 15-19 (Family: none)

Document 6: US, 5679603, A (MITSUBISHI ELECTRIC CORPORATION), 21 October 1997 (21.10.97), column 14, lines 20-41; column 16, lines 3-5; Fig. 8 & JP, 7-263365, A, [0085], [0095] Document 7: US, 6336970, B1 (DOWA MINING CO., LTD.), 08 January 2002 (08.01.02), Figs. 1-4

& JP, 2000-124138, A, Figs. 1-4 Document 8: JP, 2003-282455, A (NEC CORPORATION), 03 October 2003 (03.10.03), full text (Family: none)

Claims 1-3, 11-21, 29-37

The subject matter of claims 1-3, 11-21, and 29-37 is not novel on account of documents 1, 2, and 3 respectively.

Document 1 describes introducing hydrogen chloride for etching and TMGa and AsH₃ for growth, simultaneously removing the surface modified layer or oxide film layer, and then growing an active layer.

Document 2 describes using TMG simultaneously with hydrogen chloride etching gas when etching in order to clean the growth surface immediately before vapor-phase growth of a compound semiconductor thin film.

Document 3 pertains to cleaning a semiconductor surface in advance when epitaxially growing a semiconductor layer on a semiconductor substrate, and describes supplying a gas containing starting material for epitaxial growth and a gas containing a halogen element in a predetermined ratio.

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Supplemental Box

(To be used when the space in any of the preceding boxes is not sufficient)

Continuation of Box V:

Claim 38

The subject matter of claim 38 does not involve an inventive step on account of documents 1-3 and document 6.

Document 6 describes supplying HCl gas before growing p-InP layer 3a and thinly and lightly etching the oxidized surface layer when forming a p-InP layer 3 and using a SiO2 stripe 50 as a mask and removing the SiO₂ stripe 50 and growing the p-InP layer 3a.

Employing the method described in documents 1-3 instead of the light etching step in document 6 would be easy for a person skilled in the art.

Claims 4-10, 22-28, 39-48

The matters specified in claims 4-10, 22-28, and 39-48 are not disclosed in any of the documents cited in the ISR, except for document 8, which has the same applicant as the present application, and is not obvious to a person skilled in the art.